

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Applicant: Alexander Hauser et al.

Serial No.: 10/555,141

Filed: October 31, 2005

Title: METHOD FOR TEXTURING
SURFACES OF SILICON
WAFERS

Group Art Unit: 2812

Examiner: Mohsen Ahmadi

Docket No.: RAC0082

Conf. No.: 2898

Customer No.: 00832

CERTIFICATE UNDER 37 C.F.R. 1.8(B)

I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office to the attention of: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Anthony Niewyk, Reg. No. 24,871

Name of Registered Representative

Signature

June 21, 2006

Date

AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 24, 2006, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.